



TFW

Docket No.: SON-2811  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: PCT/JP03/11016  
Kaoru KOIKE

Application No. 10/526,359

Confirmation No. 8957

Filed: October 18, 2005

Art Unit: 2856

For: ALIGNMENT METHOD, ALIGNMENT  
SUBSTRATE, PRODUCTION METHOD OF  
ALIGNMENT SUBSTRATE, EXPOSURE  
METHOD, EXPOSURE APPARATUS AND  
PRODUCTION METHOD OF MASK

**REQUEST FOR CORRECTED FILING RECEIPT**

**Attention: PCT Section  
Office of Initial Patent Examination's  
Filing Receipt Correction**

Sir:

1. Attached is a copy of the official filing receipt received from the PTO in the above application for which issuance of a corrected filing receipt is respectfully requested.
2. There is an error with respect to the following, which is incorrectly entered. We are also enclosing a copy of the executed declaration showing the correct data.

**Error:**

**Correct data to title:**

1. Title

1. Alignment Method, Alignment Substrate,  
Production Method of Alignment Substrate,  
Exposure Method, Exposure Apparatus and  
Production Method of Mask

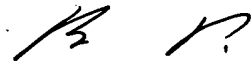
2. Assignee

2. Sony Corporation

3. The correction is due to an error by the USPTO. If any fee is due, please charge Deposit Account No.18-0013.

Dated: March 27, 2006

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UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/526,359	10/18/2005	2856	1630	SON-2811	13	20	6

CONFIRMATION NO. 8957

23353

RADER FISHMAN & GRAUER PLLC  
 LION BUILDING  
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 WASHINGTON, DC 20036

FILING RECEIPT



\*OC000000017938677\*

Date Mailed: 01/31/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. **If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).**

**Applicant(s)**

Kaoru Koike, Ibaraki, JAPAN;

**Assignment For Published Patent Application**

Sony Corporation, Tokyo, JAPAN

**Power of Attorney:** The patent practitioners associated with Customer Number **23353**.**Domestic Priority data as claimed by applicant**

This application is a 371 of PCT/JP03/11016 08/29/2003

**Foreign Applications**

JAPAN P2002-256369 09/02/2002

**Projected Publication Date:** 05/11/2006**Non-Publication Request:** No**Early Publication Request:** No**Title**

Alignment method, alignment substrate, production method <sup>or</sup> alignment substrate, exposure method, exposure system and mask producing method <sup>or MASK</sup>

Preliminary Class

073

APPARATUS

production

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